

AMENDMENTS TO THE SPECIFICATION:

Please correct the title of the application in the PCT Publication with the English language translation of the specification and insert the following new paragraph:

COATING LIQUID FOR FORMING AMORPHOUS SILICA-BASED COATING FILM
WITH LOW DIELECTRIC CONSTANT AND METHOD FOR PREPARING THE SAME

RELATED APPLICATIONS

The present application is based on International Application No. PCT/JP03/13690 filed October 27, 2003, and claims priority from, Japanese Application Number 2002-318417, filed October 31, 2002, the disclosure of which is hereby incorporated by reference herein in its entirety.